Patent Assignment Abstract of Title

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Publication #: NONE

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Inventor: Cheng Chi Wang

Title: Transflective liquid crystal display

Assignment: 1

Reel/Frame: 012277/05

Recorded:

Mailed:

10/19/2001

01/07/2002

Conveyance: ASSIGNMENT OF ASSIGNORS INTEREST (SEE DOCUMENT FOR DETAILS).

Assignor: WANG, CHENG CHI

Exec Dt: 07/20/2001

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	r Hits	Search Text	DB UCDATE:	Time stamp
1	128	349/114.ccls.	USPAT;	2003/03/13 09:4
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3	884	transflect\$3	USPAT;	2003/03/13 09:4
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4	886374	aluminum	USPAT;	2003/03/13 09:5
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8	52866	transmittance	USPAT;	2003/03/13 09:5
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10 :	156616	sputter\$3	USPAT;	2003/03/13 09:5
			US-PGPUB;	
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11	2862100	pressure		2003/03/13 09:5
11	2862100	pressure	DERWENT; IBM_TDB USPAT;	2003/03/13 09:5
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15	0	transflect\$3 same ((aluminum adj nitride)	USPAT;	2003/03/13 09:53
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16	258	((aluminum adj nitride) aln) same sputter\$3	USPAT;	2003/03/13 09:53
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18	276	aluminum near10 transmittance	USPAT;	2003/03/13 09:54
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3	1203378	electrode	USPAT;	2003/03/13 10:28
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4 .	884	transflect\$3	USPAT;	2003/03/13 10:31
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5	4	(aluminum near10 thick\$4) near10 electrode same transflect\$3	USPAT;	2003/03/13 10:38
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6	16	(aluminum near10 thick\$4) same transflect\$3	IBM_TDB USPAT;	2003/03/13 11:39
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2	128	349/114.ccls.	USPAT;	2003/03/13 10:41
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7	20259	aluminum adj nitride	USPAT;	2003/03/13 11:41
1 .		diaminam day mining	US-PGPUB;	2003,03,13 11:11
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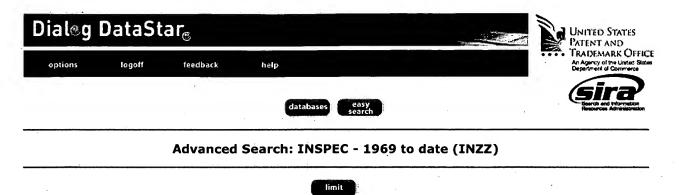
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